IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Eui-Hyeok Yang Art Unit: 1763
Serial No.: 10/678,359 Examiner: George A. Goudreau
Filed : October 2, 2003
Title : WAFER LEVEL TRANSFER OF MEMBRANES WITH GAS-PHASE ETCHING AND WET ETCHING METHODS

Mail Stop Amendment
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

In response to the Office action mailed October 11, 2006, please amend the application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.